## Microscopic Investigation of Mono-layer/Multi-layer self-assembled InAs QDs on GaAs<sub>1-x</sub>Sb<sub>x</sub>/GaAs Composite Substrates for Photovoltaic Solar Cells

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The maximum energy conversion efficiency of a photovoltaic (PV) solar cell consisting of single-junction semiconductor layer is limited by the Shockley-Queisser (SQ) effect, which is ~ 31% under one sun illumination according to theoretical calculation [1]. In order to increase the efficiency, multi-junction and multi-transition approaches have been proposed. These schemes aim to allow subband gap absorption by introducing intermediate states within the band gap of the barrier material in order to increase photocurrent [2]. Quantum dots (QDs) are considered as a promising candidate material for multiple transition solar cells because of their discrete density of states, which would favor the formation of a quasi-Fermi level discontinuity between the bulk and the confined materials [3]. Formation of self-assembled InAs QDs embedded in GaAs<sub>1-x</sub>Sb<sub>x</sub> layer has been shown to follow the Stranski-Krastanov (SK) growth mode with a lattice-mismatch of ~7% between InAs and GaAs(Sb) matrix. A set of mono-layer InAs QDs on GaAs<sub>1-x</sub>Sbx/GaAs and a set of multi-layered InAs QDs on GaAs<sub>1-x</sub>Sbx/GaAs with different Sb concentration and layer periods were grown on semi-insulated GaAs (001) substrates using molecular beam epitaxy (MBE). It is interesting to investigate the structure-growth-performance properties of this material system using electron microscopy before further utilizing them in actual photovoltaic applications. Cross-sectional TEM samples were prepared using mechanical polishing and dimpling followed by argon ion-milling. Most images were recorded using high-angle annular-dark-field (HAADF) imaging in a JEOL-2010F field-emission STEM operated at 200 keV, which provided a nominal probe size of ~2 Å. Preliminary STEM observations of InAs/GaAs<sub>1-x</sub>Sb<sub>x</sub>/GaAs QDs system are reported here.

Figure 1(a) is a schematic showing the structure of these MBE-grown self-assembled InAs QDs on  $GaAs_{1-x}Sb_x/GaAs$ . The Sb concentration is ~7% and ~10%, respectively, in order to tune the energy band alignment. Figure 1(b) is a high-resolution HAADF-STEM image revealing the cross-sectional morphology of InAs QDs on  $GaAs_{0.9}Sb_{0.1}/GaAs$ . The  $\delta$ -doping line is shown clearly, and the InAs QDs embedded into the  $GaAs_{0.9}Sb_{0.1}$  epilayer are marked by the red arrows. Multi-layered InAs QDs (10×) were grown on  $GaAs_{1-x}Sb_x/GaAs$  composite layer with the nominal Sb concentration of 8%, 15% and 20%, respectively, by varying Sb to As flux ratio. The actual Sb composition was determined to be 7.25%, 9.8% and 10.2% from XRD analysis. The stress relaxation in GaAsSb layers was found to be 0, 18% and 23%, respectively. Figures 2 (a) and (b) are typical HAADF-STEM images showing 10 periods of InAs QDs on  $GaAs_{0.93}Sb_{0.07}$  and  $GaAs_{0.902}Sb_{0.098}$ , respectively. Detailed correlation between structural morphology and optical properties will be described.

## References:

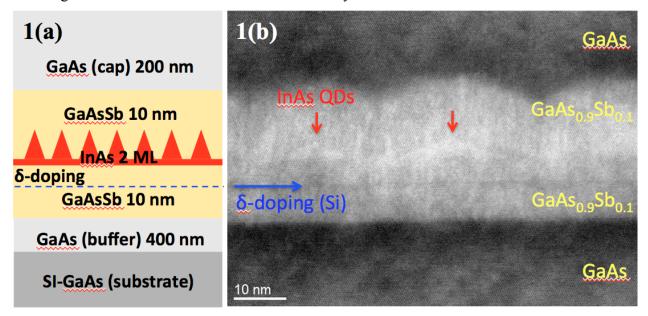
- [1] W. Shockley and H. Queisser, J. Appl. Phys. **32** (1961) 510.
- [2] A. Luque and A. Marti. Phys. Rev. Lett. **78**(1997), 5014.
- [3] A. Marti et al, Phys. Rev. Lett. 97(2006), 247701.

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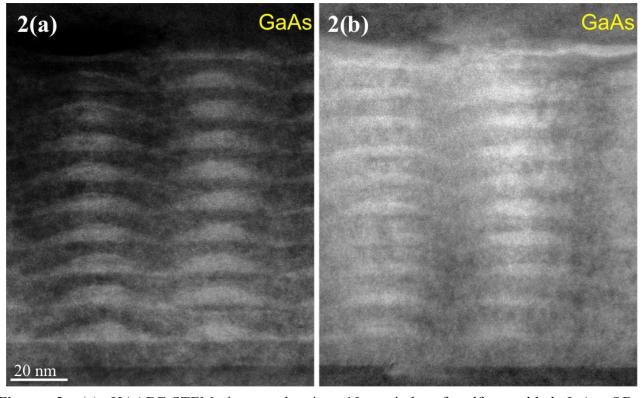
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**Figure 1.** (a) Structural schematic of monolayer self-assembled InAs QDs on GaAs<sub>1-x</sub>Sb<sub>x</sub>/GaAs. (b) HAADF-STEM image of monolayer self-assembled InAs QDs on GaAs<sub>0.9</sub>Sb<sub>0.1</sub>/GaAs.



**Figure 2.** (a) HAADF-STEM image showing 10 periods of self-assembled InAs QDs on GaAs<sub>0.93</sub>Sb<sub>0.07</sub>/GaAs. (b) HAADF-STEM image showing 10 periods of self-assembled InAs QDs on GaAs<sub>0.90</sub>Sb<sub>0.098</sub>/GaAs.